

Notice of References Cited

——————————————————————————————————————	<u>^</u>		
Application/Control No. 09/686,895	Applicant(s)/Patent Under Reexamination CHEN ET AL,		
Examiner	Art Unit		
Maria N. Von Buhr	2125	Page 1 of 1	

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,535,628	03-2003	Smargiassi et al.	382/149
	В	US-6,452,150 /	09-2002	Mori et al.	250/208.1
	С	US-6,265,736 /	07-2001	Dillen et al.	257/232
	D	US-6,163,338 /	12-2000	Johnson et al.	348/148
	Е	US-6,064,429 /	05-2000	Belk et al.	348/128
	F	US-5,644,140	07-1997	Biedermann et al.	250/559.08
	G	US-4,638,289 /	01-1987	Zottnik, Edmund	246/45
	Н	US-			
	1	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	WO 00/22655 /	04-2000	WIPO-PCT	Smargiassi et al.	/
	0					
	Р					
	Q					
	R					
	s		"			
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	w	
	x	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.